

Notice of References Cited	Application/Control No. 10/728,487	Applicant(s)/Patent Under Reexamination KLINE, CHRISTOPHER N.	
	Examiner Hong C. Kim	Art Unit 2185	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0204597	10-2003	Arakawa et al.	709/226
*	B	US-2003/0212736	11-2003	Kotnur et al.	709/202
*	C	US-2004/0073835	04-2004	Kim, Byeong-Chul	714/013
*	D	US-2004/0103079	05-2004	Tokusho et al.	707/001
*	E	US-2004/0205206	10-2004	Naik et al.	709/230
*	F	US-2004/0215998	10-2004	Buxton et al.	714/002
*	G	US-2004/0250162	12-2004	Halley et al.	714/013
*	H	US-2005/0010709	01-2005	Davies et al.	710/305
*	I	US-6,697,866	02-2004	Arakawa et al.	709/229
*	J	US-6,728,751	04-2004	Cato et al.	709/202
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	I					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.